



GP/176  
**PATENT**  
**MIC04 P-106**

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group : 1763  
Applicant : Imad Mahawili, PhD  
Serial No. : 09/488,309  
Filed : January 20, 2000  
For : REACTOR WITH REMOTE PLASMA SYSTEM AND  
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Attention: Official Draftsman  
Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

**TRANSMITTAL OF FORMAL DRAWINGS**

Applicant requests that the enclosed five (5) sheets of formal drawings be entered in the above identified application.

**REMARKS**

Enclosed please find five (5) sheets of formal drawings for filing in the present application. The enclosed drawings correspond to the informal drawings now on file.

Respectfully submitted,

IMAD MAHAWILI, PHD

By: Van Dyke, Gardner, Linn & Burkhart, LLP

September 12, 2000  
Date

CSC:lmsc

  
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Dear Sir:

CERTIFICATE OF MAIL

I certify that the attached return postcard, Transmittal of Formal Drawings,  
and five (5) sheets of formal drawings are being deposited with the United States Postal  
Service as first class mail in an envelope addressed to:

Attention: Official Draftsman  
Assistant Commissioner for Patents  
Washington, D.C. 20231

on September 12, 2000.

*Lynette M. S. Clark*  
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CSC:lmsc  
Enclosures

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